



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

MIKHAYLICH et al.

Application No: 10/766,733

Filed: January 27, 2004

For: METHOD AND SYSTEM FOR CLEANING
A SEMICONDUCTOR WAFER

) Attorney Docket No: LAM1P108D

)

) Examiner: MARKOFF, A.

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) Group Art Unit: 1746

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) Date: **June 12, 2006**

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on **June 12, 2006**.

Signed: _____

Sylvia Castillo

AMENDMENT

Mail Stop AF
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is in response to a Final Office Action dated March 8, 2006, term to respond extends to June 8, 2006. A one month extension of time is petitioned for to extend the time for response to July 8, 2006.

Furthermore, enclosed with this Amendment is a Request for Continued Examination (RCE). Please enter this Amendment and remarks.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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